

10/583725

Docket No.: HEI-019

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Higashi KO : Confirmation No.
U.S. Patent Application No.: ----- : Group Art Unit: -----
Filed: June 20, 2006 :

For: GUTTER BLOCK STRUCTURE, WATER CHANNEL FORMED BY GUTTER
BLOCK STRUCTURES, AND METHOD OF MANUFACTURING GUTTER
BLOCK STRUCTURE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed with the application and no certification or fee is required.

Respectfully submitted,

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INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)				ATTY. DOCKET NO. HEI-019		U.S. APPLICATION NO. 10/383723 Not yet assigned	
				APPLICANT Higashi KO			
				FILING DATE June 20, 2006		GROUP	
U.S. PATENT DOCUMENTS							
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE	
FOREIGN PATENT DOCUMENTS							
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
	2001-003343	01/09/2001	Japan			X	
	2000-144689	05/26/2000	Japan			X	
	08-269936	10/15/1996	Japan			X	
	2002-129642	05/09/2002	Japan			X	
	H06-67532	09/22/1994	Japan				X
	H07-8430	02/07/1995	Japan				X
	S50-21926	06/16/1973	Japan				X
	H06-26569	07/20/1994	Japan				X
	2002-242161	08/28/2002	Japan			X	
	S62-251103	10/31/1987	Japan				X
	H4-77681	07/07/1992	Japan				X
	S60-483	01/05/1985	Japan				X
	08-277535	10/22/1996	Japan			X	
	2002-129535	05/09/2002	Japan			X	
	2000-202479	07/25/2000	Japan			X	
	08-184095	07/16/1996	Japan			X	
	08-284136	10/29/1996	Japan			X	
	11-303045	11/02/1999	Japan			X	
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER				DATE CONSIDERED			

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.